

In re Application of: KAMIYAMA et al.
Application No. 10/811,979
Filed: March 30, 2004
For: SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME, APPARATUS FOR FORMING FILM, AND METHOD FOR FORMING HIGH-DIELECTRIC-CONSTANT FILM



U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

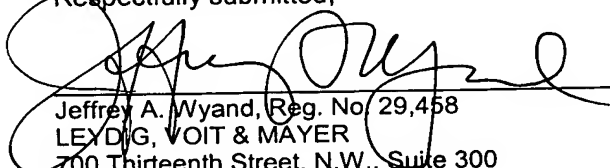
Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
- ☐ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- ☐ Other:
- ☐ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

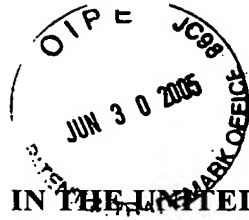
					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		none			\$ 0.00		\$ 0.00	
	subtract time extension fee previously paid	none			(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADD'L CLAIM FEE	RATE	ADD'L CLAIM FEE
TOTAL		MINUS		=	x 25=	\$	x 50=	\$
INDEPENDENT		MINUS		=	x 100=	\$	x 200=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 180=	\$	+ 360=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,


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Date: 
JAW/tps
Amendment or ROA Transmittal (Revised 1/14/05)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application No. 10/811,979

Applicant: KAMIYAMA et al.

Filed: March 30, 2004

TC/AU: 2814

Examiner: L. Pham

Docket No.: 403018

Customer No.: 23548

Commissioner for Patents
U.S. Patent and Trademark Office
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401 Dulany Street
Alexandria, VA 22314

REPLY TO OFFICE ACTION

Sir:

In reply to the Office Action dated June 2, 2005, please enter the following amendments and consider the following remarks.

Amendments to the Title are on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.

AMENDMENTS TO THE TITLE

Replace the title with:

~~SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME,~~
~~APPARATUS FOR FORMING FILM, A SEMICONDUCTOR DEVICE AND~~
METHOD FOR FORMING HIGH-DIELECTRIC-CONSTANT FILM